

312	Subclass
430	Class
ISSUE CLASSIFICATION	

5340700

UTILITY SERIAL NUMBER	08/149122	PATENT DATE	AUG 2 1993	PATENT NUMBER	5340700
SERIAL NUMBER	08/149,122	FILING DATE	11/03/93	CLASS	430
		SUBCLASS	312	GROUP ART UNIT	1503

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CONTINUING DATA***

VERIFIED THIS APPLN IS A CON OF 07/863,791 04/06/92 abandoned 12-23-93

FOREIGN/PCT APPLICATIONS***

VERIFIED

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FOREIGN FILING LICENSE GRANTED 12/10/93

Foreign priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	AS FILED	STATE OR COUNTRY	SHEETS DRWGS.	TOTAL CLAIMS	INDEP. CLAIMS	FILING FEE RECEIVED	ATTORNEY'S DOCKET NO.
35 USC 119 conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	TM	CA	7	20	3	\$710.00	57017.P025C
Verified and Acknowledged			Examiner's Initials					
ADDRESS			BEAREEY, SOKOLOFF, TAYLOR & ZAEMAN 12400 WILSHIRE BLVD., SEVENTH FLOOR LOS ANGELES, CA 90025					
TITLE			METHOD FOR IMPROVED LITHOGRAPHIC PATTERNING IN A SEMICONDUCTOR FABRICATION PROCESS					
U.S. DEPT. of COMM.-Pat. & TM Office - PTO-436L (rev. 10-78)								

PARTS OF APPLICATION
FILED SEPARATELY

NOTICE OF ALLOWANCE MAILED		1-10-94		Terressa Mosler		CLAIMS ALLOWED	
				Assistant Examiner		Total Claims 22	
ISSUE FEE		Amount Due 11/10/93		Date Paid 4-11-94		DRAWING	
				JOHN KIGHT, III. SUPERVISORY PATENT EXAMINER GROUP 1500		Sheets Drwg. 7	
				Primary Examiner		Figs. Drwg. 15	
				PREPARED FOR ISSUE		Print Fig. 1a	
						ISSUE BATCH NUMBER 409	
Label Area		WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368. Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.					